



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

June 15, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG809651871

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

8.67 - 8.70 X 5.36 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

2.50 CARATS

D

VS 1

EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

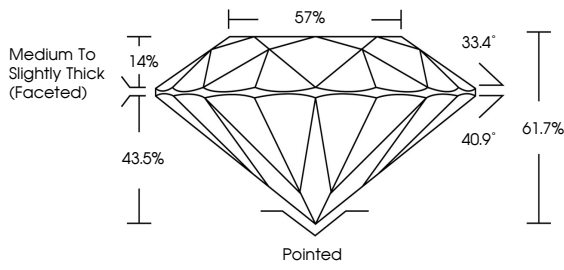
EXCELLENT

NONE

 LG809651871

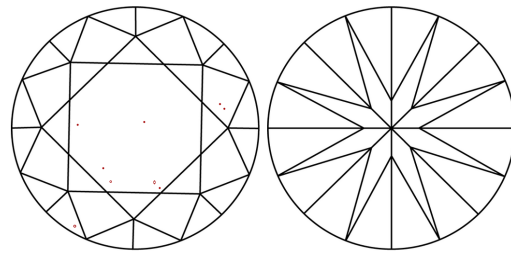
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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ROUND BRILLIANT

8.67 - 8.70 X 5.36 MM

Carat Weight

Color Grade

Clarity Grade

Cut Grade

Depth

Table

Girdle

Medium To Slightly Thick (Faceted)

Pointed

Polish

Symmetry

Fluorescence

Inscription(s)

2.50 CARATS

D

VS 1

EXCELLENT

61.7%

57%

None

EXCELLENT

EXCELLENT

NONE

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